

WEST Search History

DATE: Tuesday, May 27, 2003

<u>Set Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
side by side			result set
<i>DB USPT; PLUR YES; OP OR</i>			
L16	l1 and l14	1	L16
L15	L14 and l4	0	L15
L14	l11 or l12 or l13	48	L14
L13	higashikawa adj makoto.in.	4	L13
L12	matsuda adj koichi.in.	39	L12
L11	kondo adj takaharu.in.	9	L11
L10	l8 and L9	31	L10
L9	((427/\$7)!.CCLS.)	81829	L9
L8	l6 and L7	72	L8
L7	electrode and substrate	131390	L7
L6	l4 and l5	85	L6
L5	power and frequency and pressure	95593	L5
L4	l2 and l3	101	L4
L3	plasma near2 (CVD or vapor adj deposition)	15213	L3
L2	hydrogen same l1	666	L2
L1	silicon adj (halide or fluoride or chloride)	2649	L1

END OF SEARCH HISTORY